

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?: NONE
Title:: SEMICONDUCTOR PRESSURE
SENSOR DEVICE TO DETECT MICRO
PRESSURE
Attorney Docket Number:: 249106US2
Total Drawing Sheets:: 2
Small Entity?: NO

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: JAPAN
Status:: FULL CAPACITY
Given Name:: Hajime
Family Name:: KATO
City of Residence:: TOKYO
Country of Residence:: JAPAN
Street of Mailing Address:: c/o MITSUBISHI DENKI KABUSHIKI
KAISHA,
2-3, Marunouchi 2-chome, Chiyoda-ku,
City of Mailing Address:: TOKYO
Country of Mailing Address:: JAPAN
Postal or Zip Code of Mailing Address:: 100-8310

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

FOREIGN PRIORITY INFORMATION

Application Number:	Country:	Filing Date:	Priority Claimed:
2003-286725	Japan	08/05/03	YES

ASSIGNMENT INFORMATION

Assignee Name::	MITSUBISHI DENKI KABUSHIKI KAISHA
Street of Mailing Address::	2-3, Marunouchi 2-chome, Chiyoda-ku
City of Mailing Address::	TOKYO
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